INDEX

Abbe erecting system, 221 Type A prism, 225, 226 Type B prism, 225, 226 version of Porro, 220 Aberration compensator, 535, 543 Absorption light, 13, 197, 199, 371 thermal, 4, 629 Acceleration PSD, 6 Adaptive mirror, 433 optics, 334 Air bags, 453 Aligning, 525 microscope objectives, 527 Alignment, 131, 414, 428, 514 accuracy, 410 device, 520 Aluminum reflective coating, 223 AlumiPlate, 422 Amici prism, 216, 217, 218, 228 Annular rings, 457 Antireflection, 299 coated, 184, 185, 186 coatings, 25, 289, 297, 526 Assembly all plastic, 161, 162 drop in, 134, 135 epoxy-bonded, 700 lathe, 135 poker chip, 141 Athermalization, 586, 612 techniques, 585 Axial compliance, 612, 616 preload, 602 Axicon prism, 237, 238 Baker-Nunn, 157

Bauernfeind prism, 233, 234 Beam footprint, 303 Beamcombiner, 215 Beamprint, 301 Beamsplitter, 215, 216 Bent optic, 582 Bevel, flat, 105 Binocular, 152, 170, 513, 673

M19, 154, 177, 673 objective, 635, 637 Biocular prism, 242 Bipod, 343, 482, 483, 494, 495, 497, 592 Birefringence, 3, 21, 23, 25 Bonded mirror, 367 mirror mountings, 366 optics, 630 prism, 274 Bonding, 274, 276, 279, 280, 281, 282, 284, 366, 368, 371, 372, 375, 381, 383, 386 boss, 382 lens, 515 Brazed, 315, 337, 343, 345 Burnished, 527, 535 Camera, 157 lens, 137, 138 objective, 135, 137, 662 Cantilevered, 92 spring, 260, 695 Cast mirror, 314-316 Catadioptric, 658 Cell, burnished, 75, 76 Chandra telescope, 433 Clocked, 131 Coating, 299 Coefficient of thermal defocus, 590, 592 Compressive contact stress, 559 Conductive coating, 184 Contact areas, 274 Contamination, 1, 3, 5, 11, 13, 38, 506 Continuous circular flange, 363, 610, 622, 695 Contoured-back configurations, 304 Controlled grinding, 557, 559 Cooling, rapid, 623, 624 Core, 328 Corrosion, 1, 3, 5, 11, 12, 28, 661 resistance, 378, 422 Counterweighted lever-type mountings, 465 Cube corner prism, 215, 238, 239, 240, 379 Cylindrical pad, 268, 565, 566

Deformation, 441, 457 contours, 448 Delta prism, 230, 231, 232 Differential thread, 146, 165, 166, 167 Diopter adjustment, 168, 169, 171, 172 Dispersing prism, 242, 244 Dispersion, 21, 27, 243, 244, 245, 666, 676, 678 Dome, 188, 189, 192, 193, 199, 201, 202 Double-arch mirror, 699 Double-sided prism, 279 Dove prism, 206, 222, 223, 225, 227, 230, 274 double, 206, 223, 224, 227, 272 Dowel pin, 427 DR, 449 Drop-in assembly, 134, 135, 511 Dual collimator, 689 Dual-roller chain support, 448 Dynamic relaxation (DR), 449, 450

Earth orbit, 16 Echellette Spectrograph/Imager (ESI), 676 Edge-contacted lens, 133 Egg crate, 318, 319 Elastomer, 106 ring, 109, 513 Elastomeric, 258 bonding, 353 Electroless nickel (ELN), 337, 345, 422, 423 plating, 338, 422 Erosion, 1, 3, 14, 184, 185, 200, 557 Error budget, 30, 33, 420, 495, 681 Evepiece module, 177

Factor, $a_{G.}$, 10 Far Ultraviolet Spectroscopic Explorer (FUSE), 681 Finite-element analysis (FEA), 7, 109, 139, 331, 370, 423, 450, 454, 459, 485, 487 analyses, 464, 495, 506, 696 model, 482, 483, 501, 639 modeling, 639 techniques, 331 Fit interference, 77, 83, 84, 139 ring threads, 85 Flange, 190, 513, 580, 605, 616 circular, 181 clamping, 582, 583 retaining, 94, 662 Flange-like deflections, 605 Flange-type retainer, 157, 625 Flat bevel, 625, 653, 655 interface, 576 Flat pad, 268 Flexure, 280, 360, 391, 408, 412, 413, 416, 417, 421, 679 assemblies, 389 axis, 478 blades, 683 interfaces, 476 link, 503 mountings, 115, 285, 380, 413, 540 rods, 473 Foam core, 328, 343, 699 mirror, 704 silicon, 332 Focus adjusting wedge system, 248, 249 Focus adjustment, 249 Force (F), 18 Four-bipod mounting, 498 Frankford Arsenal prism No. 1, 234, 235 No. 2, 234, 235 Fresnel, 25, 250 reflectance, 534 reflections, 526 Friction coefficient of, 49, 66, 363, 737 Frit bonding, 315, 322 construction, 323 Fungus, 1, 3, 14, 745

Gemini mirror, 499 telescope, 433, 455, 494 Geostationary Operational Environmental Satellite (GOES), 359 Ghost image, 289, 296, 300 imaging, 346 ray, 216 reflection, 297, 298, 299 Gold, 177, 186, 289, 295, 337, 371, 422 coated, 156, 594 plated, 588 Gravity calculations, weight and center of, 68

H₂O absorption, 727 Hale telescope, 469, 471 Heat, absorption, 629 Heating, rapid, 623 Hextek construction, 323 corporation, 324 process, 325 High pressure, 15 window, 191 High-power, high numerical aperture microscope objectives, 529 High-shock environments, 142 High temperature (T_{MAX}) , 15 Hindle mounts, 394, 471, 478 Hollow corner retroreflector (HCR), 375, 376 Horizon, 498 Horizontal axis, 484, 487 Hub mounted, 685 Hubble Space Telescope (HST), 433, 460, 465, 500, 588 Humidity, 11, 12 Hydraulic actuator, 460 mechanism, 452 mountings, 483 system, 498

Ideal

radial mount, 437, 442, 443, 451 Image orientation, 2, 293 Index of air varies with temperature, 589 Indium, 177, 181 Infrared, 641 Infrared Astronomical Satellite (IRAS), 156, 157, 419, 585, 686 Integral, 421, 428 flexure, 413, 414 mountings, 399 mounting provisions, 412 Interface, 411, 428 Interference fit, 139, 622, 668

Keck telescope, 396, 471 Kinematic mounting, 254 Kuiper Airborne Observatory, 337, 338

Lateral motion, 465 position, 465 transfer, 379 Lathe assembly, 135, 657 Law of reflection, 205 Leman prism, 236, 237 Lens bonded, 116, 117 camera, 137 element, centering, 44 multiple spring clips, 92 plastic, 122 relay, 132 threaded retainer, 363 Lever, 394 mechanism, 452, 463, 441 Light absorption, 197, 199, 371 Liquid pinning, 517, 518, 541 Locating pin, 382, 567, 569 Low earth orbit, 15 Low pressure, 15 Low temperature (T_{MIN}) , 15

Machined core, 325 Mangin, 296, 299 Manufacturing procedure, 129 Mechanisms hydraulic, 452 lever, 452 pneumatic, 452 Mercury tube edge mount, 452 supports, 451 Metal, burnished, 77 Metrology mount, 457, 460, 462, 501 Microyield strength (S_{MY}), 18 Minimum thickness, 131 Mirror hub mounting, 388, 686 Mirror mountings, 371 clamped, 353 MISR, 593, 594 MMT, telescope, 335, 488, 491, 492, 493, 494, 626 Modular construction, 152, 154, 155, 673 Modulation transfer function (MTF), 224 Molybdenum TZM, 625 Monolithic assembly, 323 closed sandwich, 339, 340 construction, 319 fused mirror blank, 321 mirror substrate, 320, 325 ULE mirror blank, 322 Mount, bonded, 60 625 Multiangle Imaging Spectro-Radiometer, 592 Multiaperture window, 185 Multiple lead thread, 168, 169 mirror telescope, MMT, 486 Multiple-point supports, 453

Neutral surface, 325, 340, 433, 445, 472 Nonkinematic, 270

OAO-C, 319 Objective, 146, 232, 388, 513, 514, 525, 532, 641, 658 module, 153 plastic, 121 reflecting microscope, 425 Ocular prism, 239, 241 Optical transfer function (OTF), 597 Orientation, 43, 294 Outgassing, 106, 177, 482, 687

Pad cylindrical, 268 elastomer, 369, 370 flat, 268 resilient, 261 Partial dispersion, 21 Pechan prism, 227 Pellicle, 346, 347

frame, 348 Penta mirror, 371, 372, 374 prism, 227, 228 roof, 373 Periscope, 293, 668 Phased, 131 Photographic application, 388 objective lens, 145, 167 Pin, 257, 566 Plastic, 120 dowelling, 517 injection-mold, 123 lenses, 160 modular assembly, 164 Pneumatic actuators, 460, 488 cylinder, 457, 491 mechanism, 452 mounting, 483, 494 Poisson's ratio (v), 19 Poker chip, 127, 141, 142, 511, 519, 538, 539, 540, 643, 644 Polishing, 465 Porro erecting system, 217 mirror, 375 prism, 208, 209, 216, 219, 220 Power spectral density (PSD), 8, 9, 742 Precision spindle, 533 Preload requirements, 65 Pressure differential, 190 Principal functions, 205 Prism Abbe Type A, 225, 226 Abbe Type B, 225, 226 Amici, 216, 217, 218, 228 apertures, 209 axicon, 237, 238 Bauernfeind, 233, 234 biocular, 242 bonded, 274 cube, 215 cube corner, 238, 239, 240 delta, 230, 231, 232 dispersing, 242, 244 double Dove, 206, 223, 224, 227, 272 double sided, 279

Dove, 206, 222, 223, 225, 227, 230, 274 Frankford Arsenal No. 1, 234, 235 Frankford Arsenal No. 2, 234, 235 Leman, 236, 237 ocular, 239, 241 Pechan, 227 penta, 227, 228 Porro, 208, 209, 216, 219, 220 reversion, 225 rhomboid, 221, 222 right angle, 206, 215 roof penta, 228, 229 Schmidt roof, 232 thin wedge, 245

Radial clearance, 621 compliance, 622, 623 effects, 617 Radiation resistant, 25 Reflecting microscope objective, 425, 529 Reflection, 206 law of, 205 Reflective coating, 211, 215, 228, 242, 289, 295 aluminum, 223 silver, 223 Refraction, law of, 205 Relay lens, 132 Resilient pad, 258, 261 Retainer, 580, 610, 664 threads, stress, 87, 88 threaded, 85, 137, 153, 180, 202, 655, 664 Reversion prism, 225 Rhomboid prism, 221, 222 Right-angle/roof penta system, 229 Right-angle prism, 206, 215 Rim, crowned, 55, 105 Ring flange, continuous annular, 84 Risley wedge system, 246, 247 Roller chain, 446 support, 445 Roof penta prism, 228, 229

Schmidt roof prism, 232 Seal. 169 dynamic, 63 elastomeric, 62 Semikinematic mounting, 254, 255 Semimonocoque, 149 Sharp corner interface 571, 572 Short wavelength spectrometer (SWS), 154, 156 Silver, 337 coating, 379, 506 reflective coating, 223 Single crystal diamond chips, 407 Single-arch lightweighted mirrors, 388 Sliding wedge, 248 SMR, 377, 378 Snap, 77, 83 SOFIA telescope, 478 Solid catadioptric lens assembly, 655 Spacer design, 127 length, 128 thin plastic, 133 SPDT, 29, 36, 37, 130, 154, 155, 337, 338, 399-415, 422, 424-429, 514, 518-519, 533, 535, 643-649,658 Spherical bearing, 388 Spherical interface, 576 Spherically mounted retroreflector (SMR), 377, 378 Spin cast, 332 Spitzer Observatory, 689 Spitzer Space Telescope, 685 Spring cantilevered, 74, 84, 260 straddling, 259, 262, 265, 268 Spring-loaded mirror mounting, 358 Strain ($\Delta L/L$), 18 Strap mount, 437, 438, 446, 450 support, 445 Stress (S), 18 generation at point, line, and area contacts, 562 optic coefficient (K_s), 19 tolerances, rule-of-thumb, 559 Swarovski Optik, 172, 269

Tangential, 574 flexures, 475 interface, 572 Tapered cross section, 609 Telescope, 232, 525 articulated, 668 objective, 143 Temperature changes, 602 gradients, 623 Thermal conductivity (k), 19 diffusivity (D), 19 expansion coefficient (CTE or α), 19 shock, 623, 625, 741 Thin plastic spacer, 133 wedge prism, 245 Threaded retainer, 363, 514, 612, 655, 695 Toroidal interface, 574 Total internal reflection (TIR), 211, 213 Tunnel diagram, 207, 208, 209

V-mount, 434, 435, 436, 437, 438, 439, 440, 441 Vacuum-tight window, 181 Vertical mirror, 457

Whiffletrees, 474, 478 Window, 629

Yield strength (SY), definition 18 Young's modulus (E), definition 18

Zeiss, 146, 170 Zenith, 498 Zernike polynomial, 543, 700, 704 Zoom attachment, 598, 599 lens, 165, 173, 600, 601, 653

Biographical Sketch of the Author



Paul R. Yoder, Jr., retired recently from a career as an independent consultant in optical engineering. For more than 50 years he conducted theoretical and experimental research in optics; designed and analyzed optical instruments; and planned, organized, and managed optical technology and electro-optical system projects ranging from conceptual studies and prototype developments to quantity production of hardware. He has held various technical and engineering management positions with the U.S. Army's Frankford Arsenal, The Perkin-Elmer Corp., and Taunton Technologies, Inc.

Yoder authored or coauthored more than 60 technical papers on optical engineering topics as well as Opto-Mechanical Systems Design (Marcel Dekker, New York, 1986 and 2nd ed., 1993); BASIC-Programme fur die Optik (Oldenbourg, Munich, 1986); Chapter 37, "Mounting Optical Components," in OSA's Handbook of Optics Vol. I (McGraw-Hill, New York, 1994); and Chapter 6 "Optical Mounts" in the Handbook of Optomechanical Engineering (CRC Press, Boca Raton). He received his B.S. and M.S. degrees in physics from Juniata College (1947) and The Pennsylvania State University (1950), respectively; he is a Fellow of SPIE, a Fellow of OSA, a member of Sigma Xi; and is listed in Who's Who in Science and Engineering. Yoder has served SPIE as a member of the board of directors 1982-1984, 1990-1992 and 1994, and was chairman of the publications committee and member of the executive committee, 1991 and 1994. He also is a founding member of SPIE's Optomechanical/Instrument Working Group. He has served as book reviews editor for Optical Engineering and as a topical editor for Applied Optics. A frequent organizer and chairman as well as an active participant in SPIE and OSA symposia, he has taught numerous short courses on optical engineering, precision mounting of optical components, principles for mounting optical components, basic optomechanical design, and analysis of the optomechanical interface for SPIE, industry, and U.S. government agencies. He also has taught two nationally broadcast courses for the National Technological University Network and has lectured at the University of Arizona and the National University in Taiwan. He received the Director's Award from SPIE in 1996, the Engineering Excellence Award from OSA in 1997, and the George W. Goddard Award from SPIE in 1999.